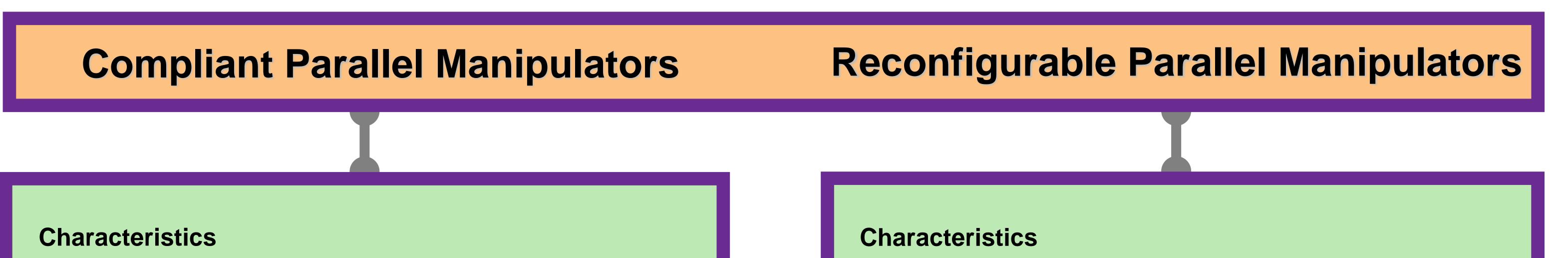
James Watt Institute tor

High Value Manufacturing

Complaint Parallel Manipulators and Disassembly-free Reconfigurable Parallel Manipulators

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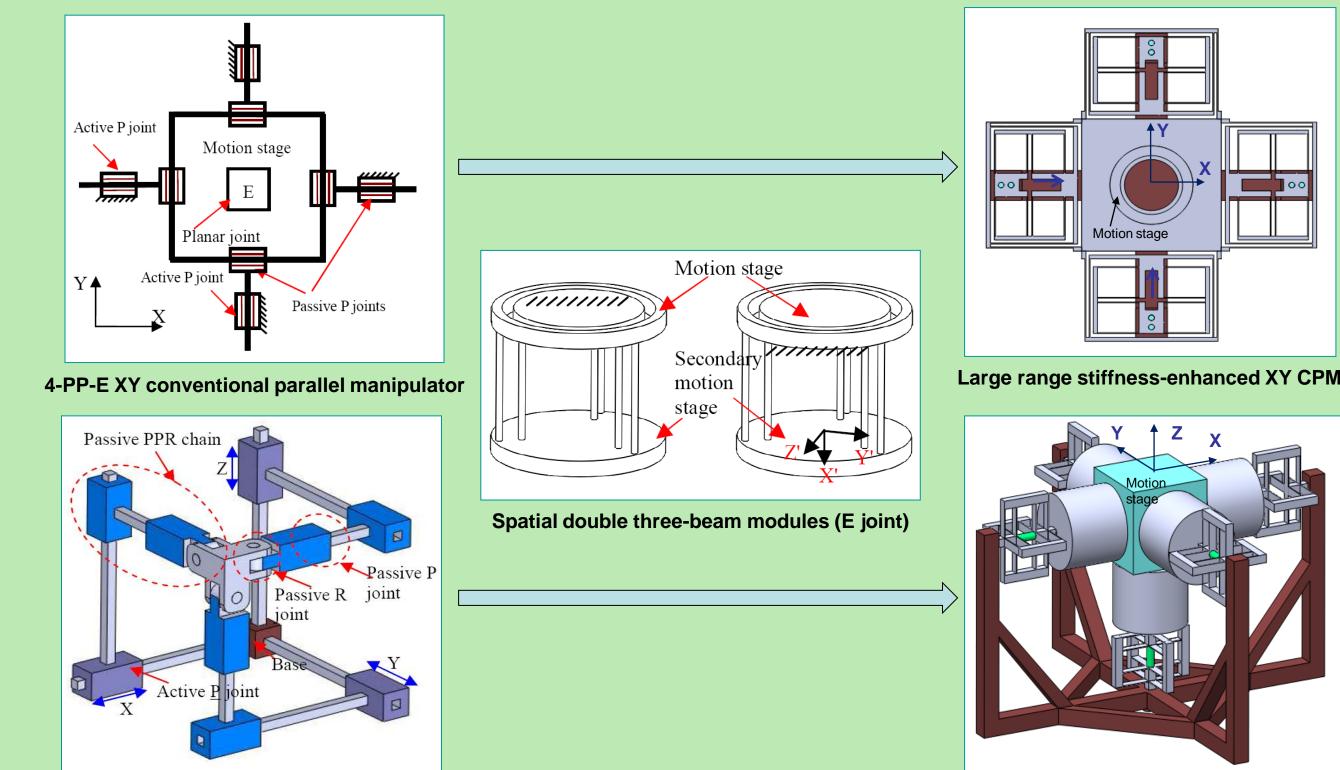


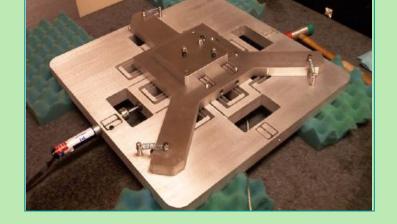


- Motion and force transmission through deformation of links
- No drawbacks such as backlash, lubrication and wear
- High accuracy
- Approximate decoupling
- Constrained parasitic motion
- Large range of motion with minimal lost motion and maximal actuation isolation

Applications

- Micro/nano-manipulation and micro-assembly
- Scanning table and bio-cell injector



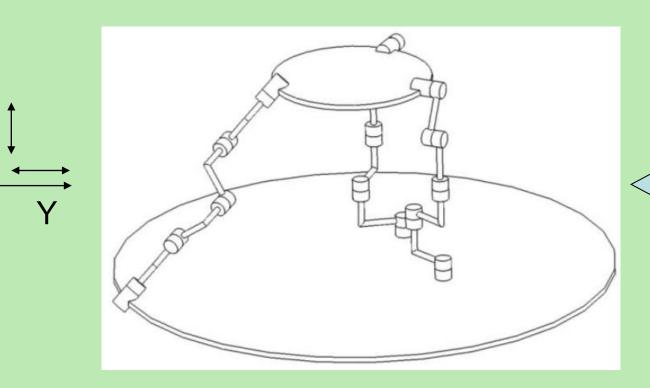


Planar XY decoupled CPM (Courtesy of Prof S. Awtar, University Michigan, USA)

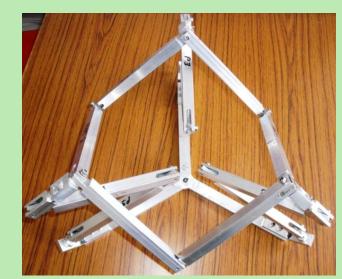
- Multiple operation modes like two or more conventional parallel manipulators
- Adaptive to variable tasks and environment
- Reconfigurable without disassembly
- Fewer actuators needed
- Reduced cost
- Simplified control

Applications

- Assembly robots
- Machine tools
- Modules of self-assembling robots
- Multi-functional products



Transitional configuration 1



3-<u>PPPR XYZ conventional parallel manipulator</u>

Large range XYZ CPM

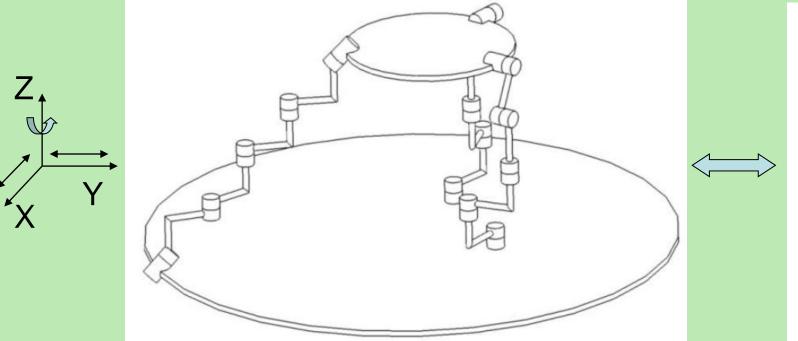
Figure 1 Large range XY and XYZ compliant parallel manipulators (CPMs).

About the novel XY CPM

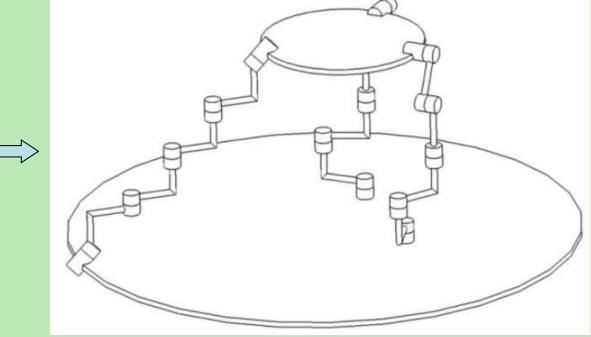
Motion range: 4mm × 4mm

About the novel XYZ CPM

- Motion range: 5mm × 5mm × 5mm
- Input(force)-output (displacement) decoupled Input(force)-Output(displacement) decoupled
- \succ Lost motion: 0.19%
- Parasitic translational displacement: <0.008mm.
- ➢ Parasitic rotational angles: <20urads</p>
- Lost motion along X/Y-axis: 0.44%
- Lost motion along Z-axis: 0.20%
- Parasitic rotational angles about X/Y-axis: <1.6×10⁻⁴urads
- Parasitic rotational angles about Z-axis: <10⁻⁶urads



Translational mode (mode 1)



Planar mode (mode 2)

Transitional configuration 2

Figure 2 Transition of a 3-degrees-of-freedom disassembly-free reconfigurable parallel manipulator from translational mode to planar mode

For details, see

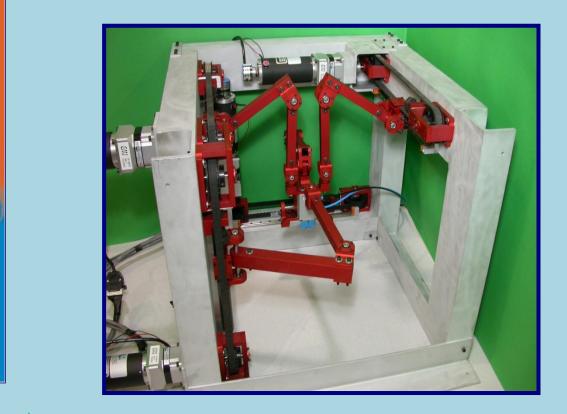
Kong, X., Proceedings of ASME 2011 International Design Engineering Technical Conferences & Computers and Information in Engineering Conference, Paper number DETC2011-48510, Washington, USA, August 28-31, 2011.

Supported by **EPSRC** through project EP/I016333/1 "Creative Design of Parallel Manipulators with Multiple Operation Modes".

Conventional Parallel Manipulators



SCARA (serial) manipulator



Based on Kong and Gosselin, U.S. patent 2006 (Courtesy of Prof C Gosselin, Laval University, Canada)

Characteristics

Actuators located on or close to the base

High payload/weight ratio

High accuracy

High velocity

A small workspace/footprint ratio

Applications

Assembly manipulators

Parallel kinematic machines (machine tools)

Haptic devices

Coordinate Measuring Machines (CMMs)

Biomedical devices

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